	Application No.	Applicant(s)	
	10/039,005	JEON ET AL.	
Notice of Allowability	Examiner	Art Unit	
	Esaw T. Abraham	2133	
The MAILING DATE of this communication appeal all claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT R of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this ap) or other appropriate communication IGHTS. This application is subject to	plication. If not included will be mailed in due course. THIS)
1. \boxtimes This communication is responsive to <u>the RCE filled on 06/</u>	<u>27/05</u> .		
2. The allowed claim(s) is/are 13-23.			
3. The drawings filed on 31 December 2001 are accepted by	the Examiner.		
 4. Acknowledgment is made of a claim for foreign priority up a) All b) Some* c) None of the: 1. Certified copies of the priority documents have 2. Certified copies of the priority documents have 3. Copies of the certified copies of the priority do International Bureau (PCT Rule 17.2(a)). * Certified copies not received: 	e been received. e been received in Application No		
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONN THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		complying with the requirements	
5. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which giv			
6. CORRECTED DRAWINGS (as "replacement sheets") mus	st be submitted.		
(a) I including changes required by the Notice of Draftspers	son's Patent Drawing Review (PTO-	-948) attached	
1) 🔲 hereto or 2) 🔲 to Paper No./Mail Date			
(b) including changes required by the attached Examiner Paper No./Mail Date	s Amendment / Comment or in the C	Office action of	
Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in t			
7. DEPOSIT OF and/or INFORMATION about the depo attached Examiner's comment regarding REQUIREMENT			
Attachment(s) 1. □ Notice of References Cited (PTO-892)	5. ☐ Notice of Informal F	Patent Application (PTO-152)	
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	6. Interview Summary	` ` ` ` ` ` ` ` ` ` ` ` ` ` ` ` ` ` ` `	
3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SB/0	Paper No./Mail Da	Paper No./Mail Date 7.	
Paper No./Mail Date4. Examiner's Comment Regarding Requirement for Deposit	8 🕅 Evaminer's Stateme	ent of Reasons for Allowance	
of Biological Material	9. Other		
C. Diological Material	SUPERVISO	BERT DECAMYCALL ORY PATENT EXAMIN' OLOGY CENTER 21	_

Application/Control Number: 10/039,005 Page 2

Art Unit: 2133

EXAMINER'S AMENDMENT

1. An examiner's amendment to the record appears below. Should the changes and

or additions be acceptable to applicant, an amendment may be filed as provided by 37 CFR

1.312. To ensure consideration of such an amendment, it MUST be submitted no latter than the

payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with

Attorney Steven Laut on 08/03/05.

2. The application has been amended as follows:

As per claim 13:

Line, 7 change "branch metric calculating means" to ---branch metric calculation means--

Examiner's statement for reason for allowance

1. Claims 22 and 22 have been previously allowed.

2. Claims 13-20 and 23 have been allowed.

The following is an examiner's statement for allowance:

As per claim 13:

The prior art taken singly or in combination fail to teach, anticipate, suggest, or render

obvious a log likelihood ratio calculator for calculating a log likelihood ratio result by receiving

the forward state metric from said state metric calculation means and reading the reverse state

metric saved at a memory in said state metric calculation means wherein the log likelihood ratio

result L_k produced by computing a function (including the formula as in claim 13) by the log

likelihood ratio calculator, wherein m is a state of a trellis diagram; k is a stage; s(m) is a

Application/Control Number: 10/039,005 Page 3

Art Unit: 2133

function a number complemented a Most Significant Bit (MSB) of binary number of m; (including the formula as in claim 13) input for a reverse state metric; forward state metric with state m and input 1; is a k^{th} reverse state metric with state s(m); A_k is a K^{th} forward state metric with state m and input 0 and B_k is a K^{th} reverse state metric with state m, and the log likelihood ratio is stored in a memory of the turbo decoder. Consequently, claim 13 is allowed over the prior art.

Claims 14-and 23, which is/are directly or indirectly dependent/s of claim 13 are also allowable over the prior art of record.

As per claim 15:

The prior art taken singly or in combination fail to teach, anticipate, suggest, or render obvious a log likelihood ratio result by receiving the forward state metric from said state metric calculation means and reading the reverse state metric saved at a memory in said state metric calculation means wherein the log likelihood ratio result L_k produced by computing a function (including the formula as in claim 15) by a first calculator, wherein m is a state of a trellis diagram; k is a stage; s(m) is a function a number complemented a Most Significant Bit (MSB) of binary number of m; (including the formula as in claim 15) input for a reverse state metric; forward state metric with state m and input 1; is a k^{th} reverse state metric with state s(m); A_k is a K^{th} forward state metric with state m and input 0 and B_k is a K^{th} reverse state metric with state m. Consequently, claim 15 is allowed over the prior art.

Claims 16-19, which is/are directly or indirectly dependent/s of claim 15 are also allowable over the prior art of record.

As per claim 20:

The prior art taken singly or in combination fail to teach, anticipate, suggest, or render obvious a log likelihood ratio result by receiving the forward state metric from said state metric calculation means and reading the reverse state metric saved at a memory in said state metric calculation means wherein the log likelihood ratio result L_k produced by computing a function (including the formula as in claim 20) by a first calculator, wherein m is a state of a trellis diagram; k is a stage; s(m) is a function a number complemented a Most Significant Bit (MSB) of binary number of m; (including the formula as in claim 20) input for a reverse state metric; forward state metric with state m and input 1; is a k^{th} reverse state metric with state s(m); A_k is a K^{th} forward state metric with state m and input 0 and B_k is a K^{th} reverse state metric with state m. Consequently, claim 20 is allowed over the prior art.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Conclusion

3. Any inquiry concerning this communication or earlier communication from the examiner should be directed to Esaw Abraham whose telephone number is (571) 272-3812. The examiner can normally be reached on M-F 8-5.

If attempts to reach the examiner by telephone are successful, the examiner's supervisor, Albert DeCady can be reached on (571) 272-3819. The fax phone numbers for the organization where this application or proceeding is assigned (571) 273-8300.

Application/Control Number: 10/039,005

Art Unit: 2133

Page 5

Information regarding the status of an Application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or PUBLIC PAIR. Status information for unpublished applications is available through Private Pair only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system,

contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Esaw Abraham

Art unit: 2133

SUPERVISORY PAYENT EXAMINER
TECHNOLOGY CENTER 2100